



Institute of Science and Technology

Quantum Optomechanical Cavity

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IPM-Tehran (29.12.2016)

Presentation outline

- Mechanical resonators
- Radiation pressure
- Optomechanical cavity
- Microwave cavity and electromechanics
- Theory of the Optomechanical cavity/cooling

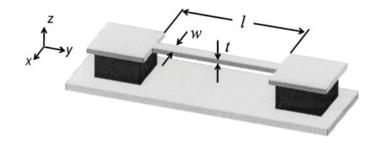
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Mechanical resonators

Radiation pressure

- Optomechanical cavity
- Microwave cavity and electromechanics

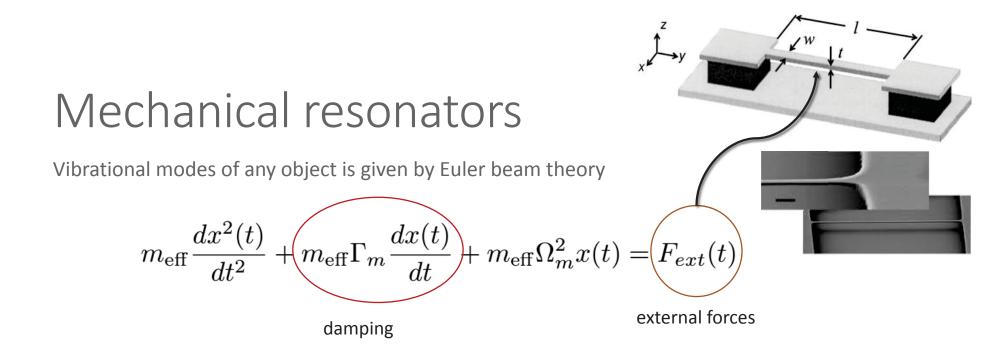
Theory of the Optomechanical cavity/cooling

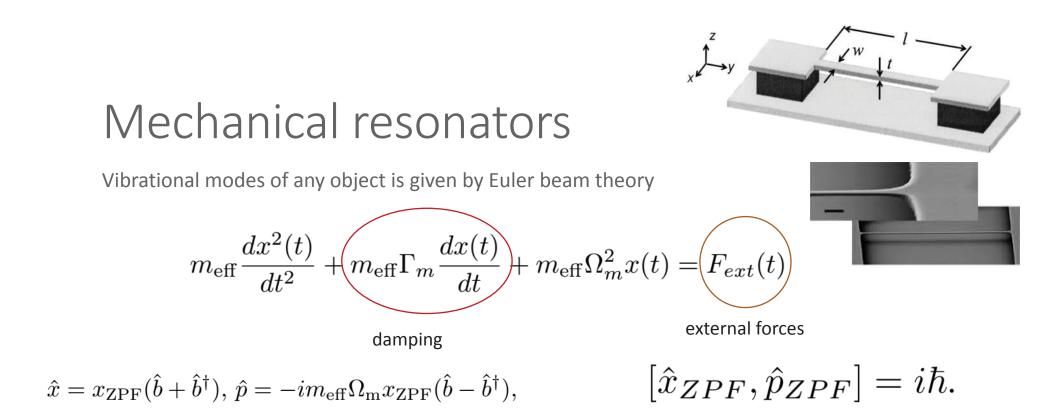


Mechanical resonators

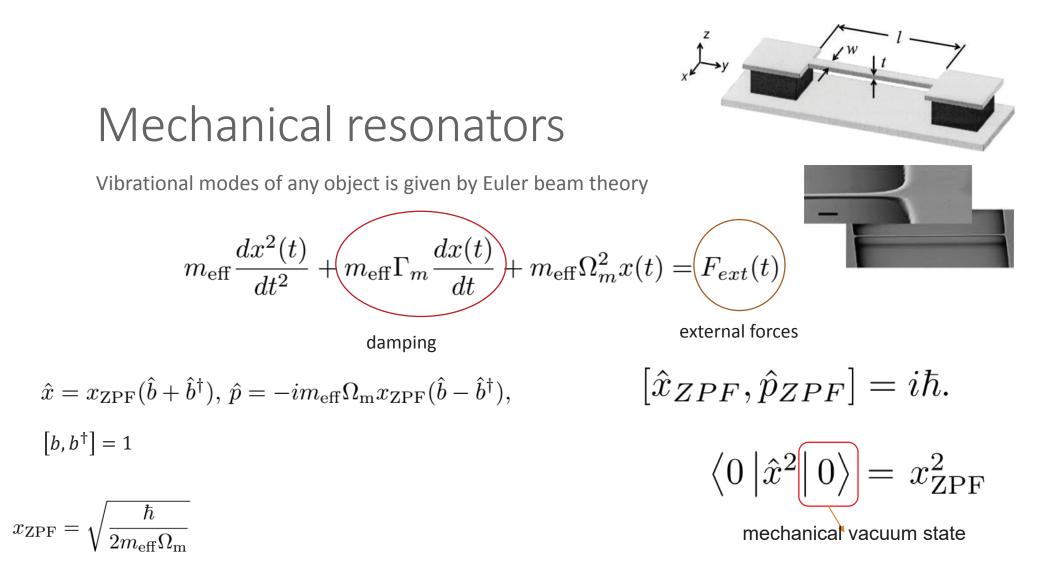
Vibrational modes of any object is given by Euler beam theory

$$m_{\rm eff}\frac{dx^2(t)}{dt^2} + m_{\rm eff}\Gamma_m\frac{dx(t)}{dt} + m_{\rm eff}\Omega_m^2x(t) = F_{ext}(t)$$

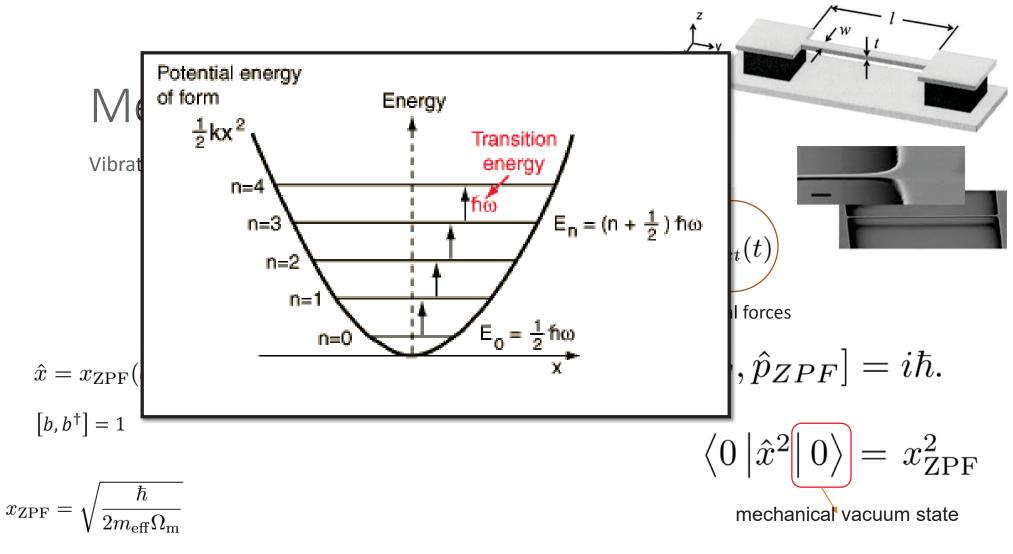




Rev. Mod. Phys. 86, 1391(2014)



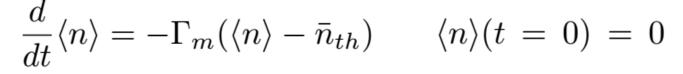
the spread of the coordinate in the ground-state



the spread of the coordinate in the ground-state

Effect of dissipation

 $n = b^{\dagger}b$



$$\langle n \rangle(t) = \bar{n}_{th}(1 - e^{-t\Gamma_m})$$

average phonon number of the environment $\bar{n}_{\rm th} = (e^{\hbar\Omega_{\rm m}/k_BT} - 1)^{-1}$





Effect of dissipation

 $n = b^{\dagger}b$

$$\frac{d}{dt}\langle n\rangle = -\Gamma_m(\langle n\rangle - \bar{n}_{th}) \qquad \langle n\rangle(t = 0) = 0$$

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average phonon number of the environment

$$\bar{n}_{\rm th} = (e^{\hbar\Omega_{\rm m}/k_BT} - 1)^{-1} \approx k_B T_{bath}/\hbar\Omega_m$$

Rate of heating out from ground state

$$\Gamma_m = \Omega_{\rm m}/Q_{\rm m}$$

$$\frac{d}{dt} \langle n(t=0) \rangle = \bar{n}_{th} \cdot \Gamma_m \approx \frac{k_B T_{bath}}{\hbar Q_m}$$

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Cold particle in the box



Effect of dissipation

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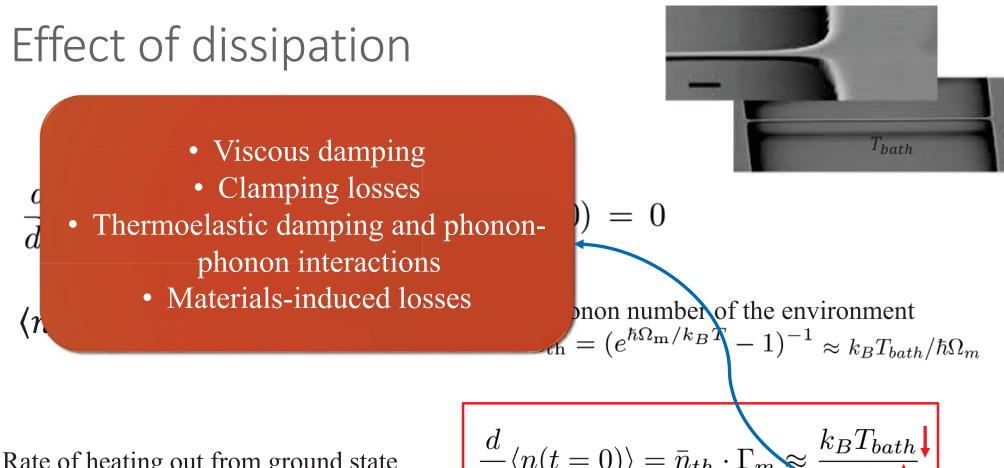
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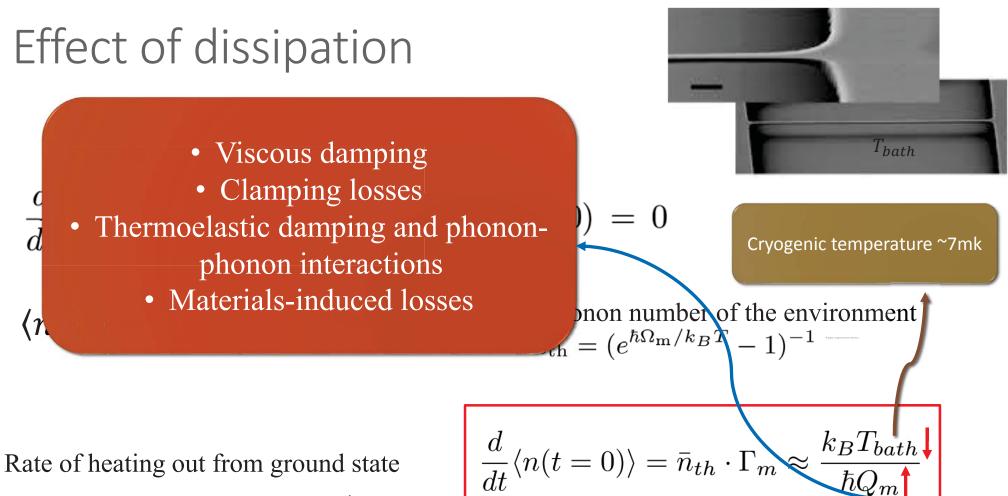
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$$\Gamma_m = \Omega_{
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* One measures the motion of a single harmonic oscillator in thermal equilibrium, one will observe a trajectory x(t) oscillating at the eigenfrequency Ωm .

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Mechanical damping and the fluctuating thermal Langevin force lead to:

✓ A randomly time-varying amplitude and phase

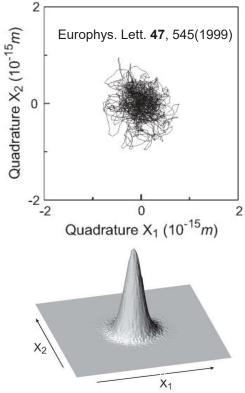
✓ Amplitude and phase change on the time scale Γ_m^{-1}

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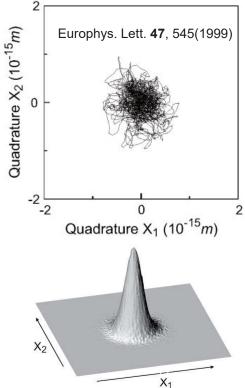
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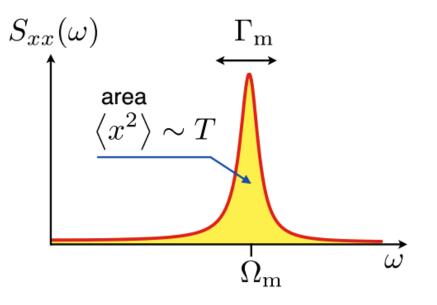
$$\tilde{x}(\omega) = \frac{1}{\sqrt{\tau}} \int_0^\tau x(t) e^{i\omega t} dt \,. \quad \stackrel{\tau \to \infty}{\longrightarrow} \qquad \left\langle |\tilde{x}(\omega)|^2 \right\rangle = S_{xx}(\omega) \,.$$
noise power spectral density

$$S_{xx}(\omega) \equiv \int_{-\infty}^{+\infty} \langle x(t)x(0)\rangle \, e^{i\omega t} \, dt = 2\frac{k_B T}{\omega} \mathrm{Im}\chi_{xx}(\omega) \,,$$

$$\chi_{xx}(\omega) = \left[m_{\text{eff}}(\Omega_m^2 - \omega^2) - im_{\text{eff}}\Gamma_m\omega\right]^{-1}$$



weak damping
$$(\Gamma_m \ll \Omega_m)$$



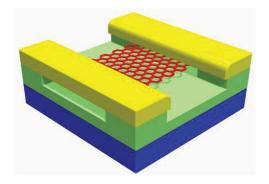
Quantum regime

$$\langle \hat{x}(t)\hat{x}(0)\rangle$$

$$S_{xx}(\omega) = \frac{2\hbar}{1 - e^{-\hbar\omega/k_B T}} \mathrm{Im}\chi_{xx}(\omega)$$

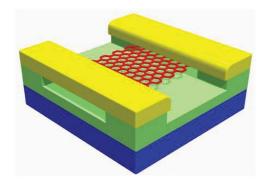
Bridges different systems with different charactristics [Phys. Scr. T 137 014001(2009)]:

- a. Coupling with several qubits: atom, ion, and molecule
- **b.** Coupling with BECs
- c. Superconducting qubits(transmon)



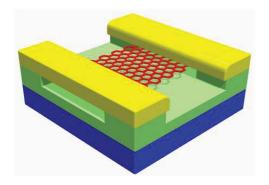
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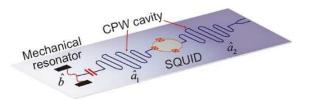
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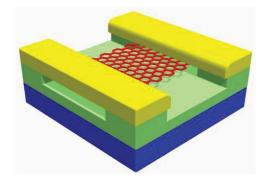
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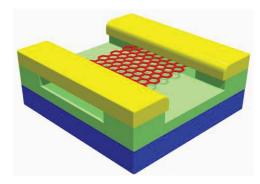


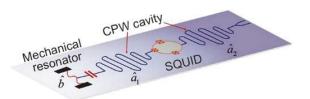
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Quantum information processing [Phys. Rev. Lett. 110, 120503(2013)](Memory, repeater)

Optical-microwave conversion [*ShB*, Phys. Rev. Lett. **109**, 130503 (2012)] Strong Nonlinearity [Phys. Rev. B **67** 134302 (2003)]



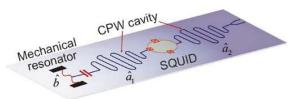


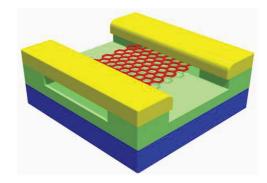
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Quantum information processing [Phys. Rev. Lett. **110**, 120503(2013)] Optical-microwave conversion [*ShB*, Phys. Rev. Lett. **109**, 130503 (2012)]

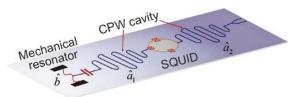
Strong Nonlinearity [Phys. Rev. B 67 134302 (2003)]

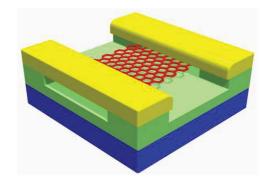




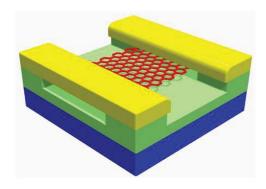
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Mechanical resonators

✓ Radiation pressure

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- Microwave cavity and electromechanics
- Theory of the Optomechanical cavity/cooling

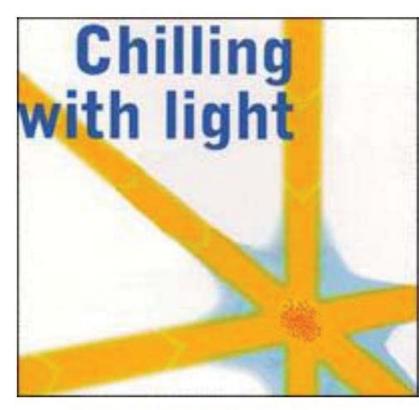
Radiation Pressure

- Effects of radiation pressure on massive matter?
- Radiation pressure on astronomic scales:





J. Keppler De Cometis, 1619 Radiation pressure on microscopic scales:



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The Nobel Prize in Physics 1997 "for development of methods to cool and trap atoms with laser light"



S. Chu





C. Cohen- W. Phillips Tannoudji

Radiation pressure

Simplest form of radiation pressure coupling is the momentum transfer due to reflection.

Single photon transfers the momentum

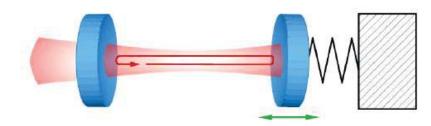
$$\begin{split} |\Delta p| = 2h/\lambda \\ \langle \hat{F} \rangle = 2\hbar \hat{k} \frac{\langle \hat{a}^{\dagger} \hat{a} \rangle}{\tau_c} = \hbar \frac{\omega}{L} \langle \hat{a}^{\dagger} \hat{a} \rangle \qquad \tau_c = 2L/c \ \text{ the cavity round trip time} \end{split}$$

the radiation pressure force caused by one intracavity photon

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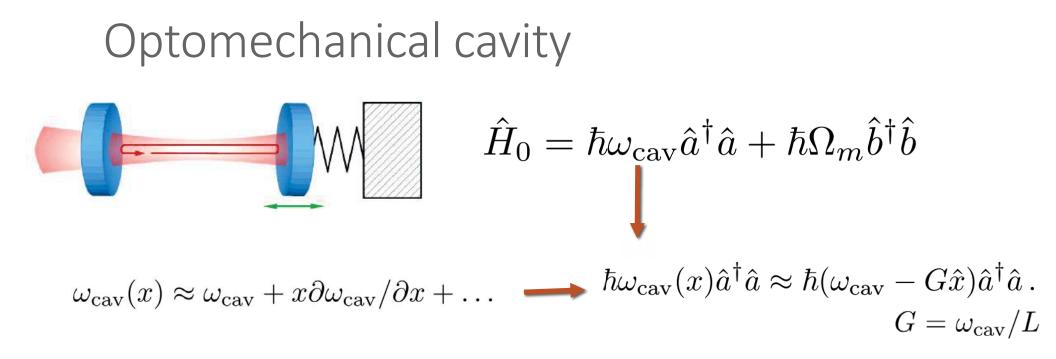
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Optomechanical cavity



$$\hat{H}_0 = \hbar \omega_{\rm cav} \hat{a}^{\dagger} \hat{a} + \hbar \Omega_m \hat{b}^{\dagger} \hat{b}$$

 $\omega_{\rm cav}(x) \approx \omega_{\rm cav} + x \partial \omega_{\rm cav} / \partial x + \dots$



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Optomechanical cavity $\hat{H}_0 = \hbar \omega_{\rm cav} \hat{a}^{\dagger} \hat{a} + \hbar \Omega_m \hat{b}^{\dagger} \hat{b}$ $\omega_{\rm cav}(x) \approx \omega_{\rm cav} + x \partial \omega_{\rm cav} / \partial x + \dots \quad \longrightarrow \quad \hbar \omega_{\rm cav}(x) \hat{a}^{\dagger} \hat{a} \approx \hbar (\omega_{\rm cav} - G \hat{x}) \hat{a}^{\dagger} \hat{a} \,.$ $G = \omega_{\rm cav}/L$ $\hat{x} = x_{\text{ZPF}}(\hat{b} + \hat{b}^{\dagger})$ $g_0 = G x_{\text{ZPF}} \longrightarrow \sim 10^{-16} m$ 1ng mass and 1MHz frequency

Optomechanical cavity $\hat{H}_0 = \hbar \omega_{\rm cav} \hat{a}^{\dagger} \hat{a} + \hbar \Omega_m \hat{b}^{\dagger} \hat{b}$ $\hbar\omega_{\rm cav}(x)\hat{a}^{\dagger}\hat{a} \approx \hbar(\omega_{\rm cav} - G\hat{x})\hat{a}^{\dagger}\hat{a}.$ $\omega_{\rm cav}(x) \approx \omega_{\rm cav} + x \partial \omega_{\rm cav} / \partial x + \dots$ $G = \omega_{\rm cav}/L$ $\hat{x} = x_{\text{ZPF}}(\hat{b} + \hat{b}^{\dagger})$ $g_0 = Gx_{\text{ZPF}} \qquad \hat{H}_{\text{int}} = -\hbar g_0 \hat{a}^{\dagger} \hat{a} (\hat{b} + \hat{b}^{\dagger})$ quency $10^{15} - 10^{19} Hz/m$

Optomechanical cavity

$$\hat{F} = -\frac{d\hat{H}_{\text{int}}}{d\hat{x}} = \hbar G \hat{a}^{\dagger} \hat{a} = \hbar \frac{g_0}{x_{\text{ZPF}}} \hat{a}^{\dagger} \hat{a}$$

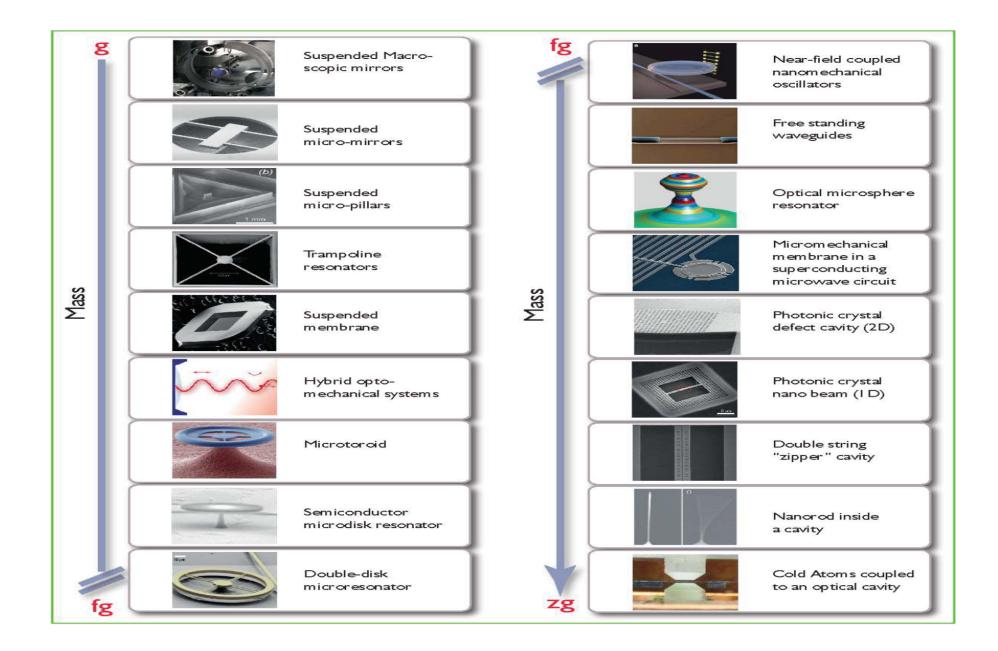
$$\omega_{\text{cav}}(x) \sim \omega_{\text{cav}} + x \partial \omega_{\text{cav}} / \partial x + \dots$$

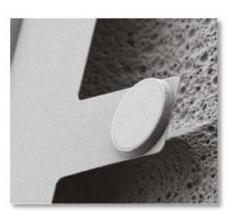
$$\hat{x} = x_{\text{ZPF}}(\hat{b} + \hat{b}^{\dagger})$$

$$g_0 = G x_{\text{ZPF}}$$

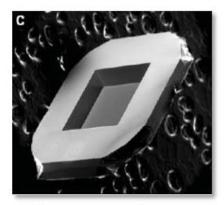
$$\hat{H}_{\text{int}} = -\hbar g_0 \hat{a}^{\dagger} \hat{a} (\hat{b} + \hat{b}^{\dagger})$$

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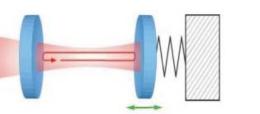




Micromirrors



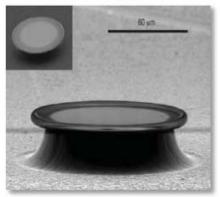
Micromembranes





Aspelmeyer (Vienna) Heidmann (Paris) Bouwmeester (St Barbara, Leiden)

Harris (Yale) Kimble (Caltech) Treutlein (Basel)



Microtoroids



Kippenberg (MPQ) Weig (LMU) Vahala (Caltech) Bowen (UQ)

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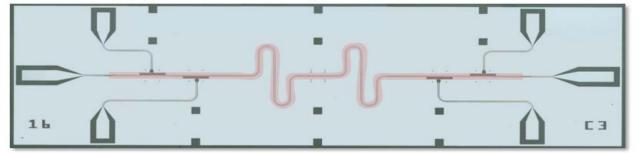
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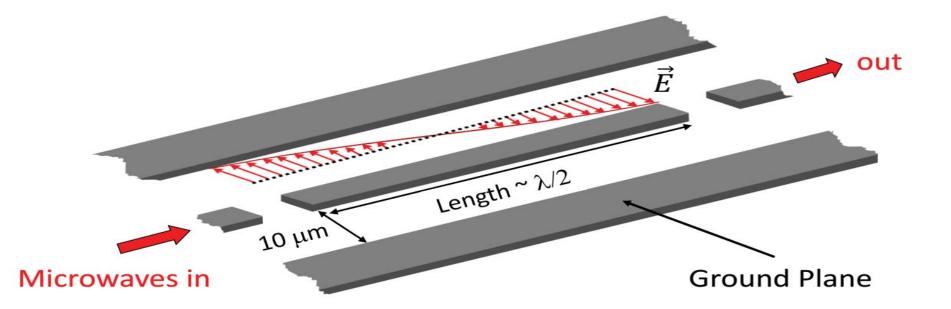
Theory of the Optomechanical cavity/cooling

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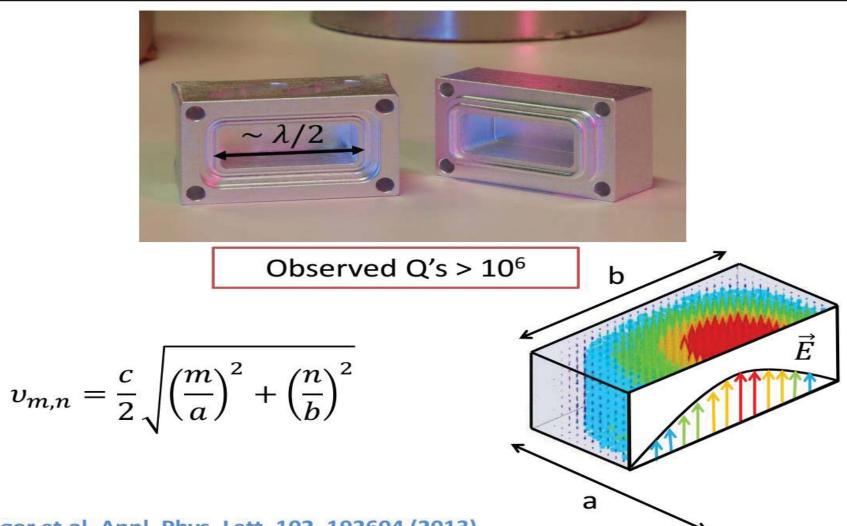
Resonators and Cavities







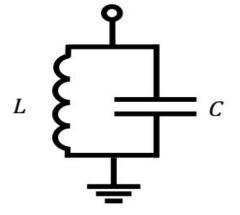
Waveguide microwave resonator



Reagor et.al. Appl. Phys. Lett. 102, 192604 (2013)

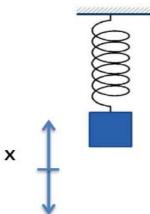
Quantum Circuits

Around a resonance:



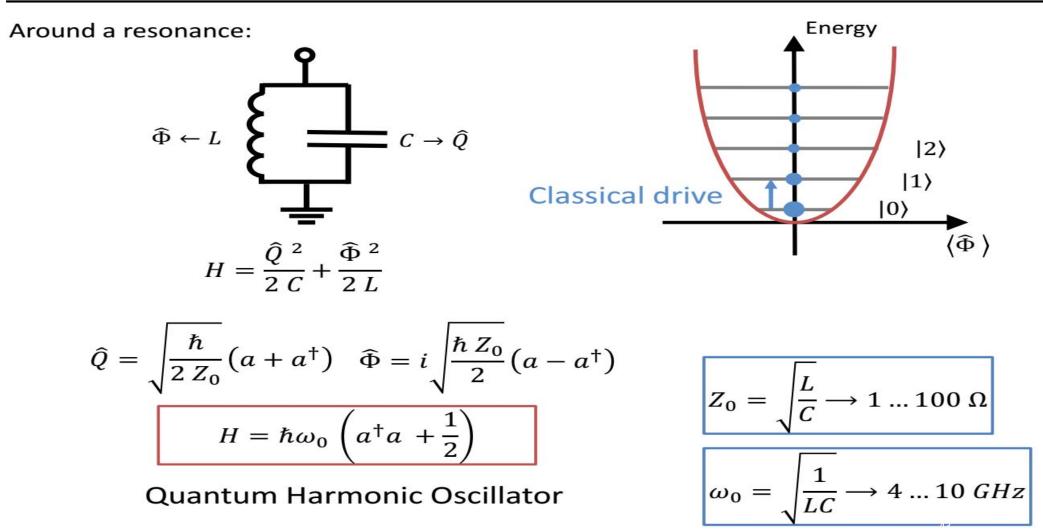
Lagrangian
$$\longrightarrow H = \frac{\hat{Q}^2}{2C} + \frac{\hat{\Phi}^2}{2L} \qquad \iff \qquad H = \frac{\hat{p}^2}{2m} + \frac{m\alpha}{2L}$$

energy in magnetic field potential energy \Leftrightarrow energy in electric field kinetic energy \Leftrightarrow



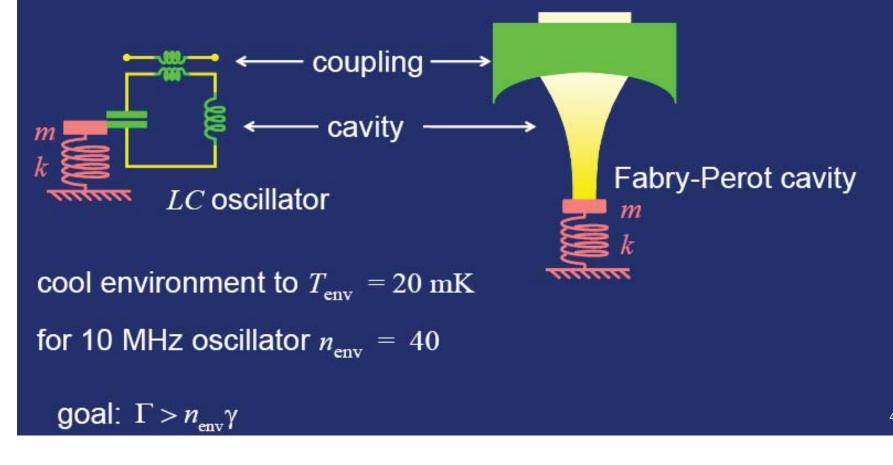
$$H = \frac{\hat{p}^{2}}{2m} + \frac{m\omega^{2}\hat{x}^{2}}{2}$$

Quantum Circuits

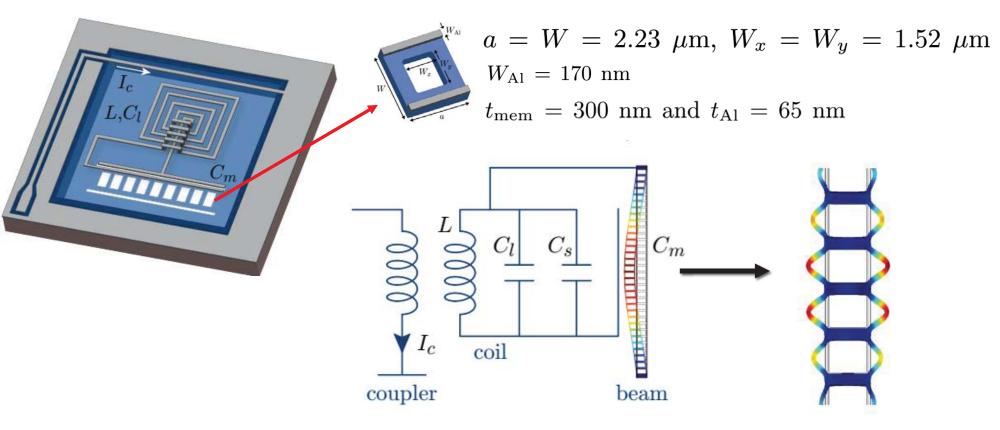


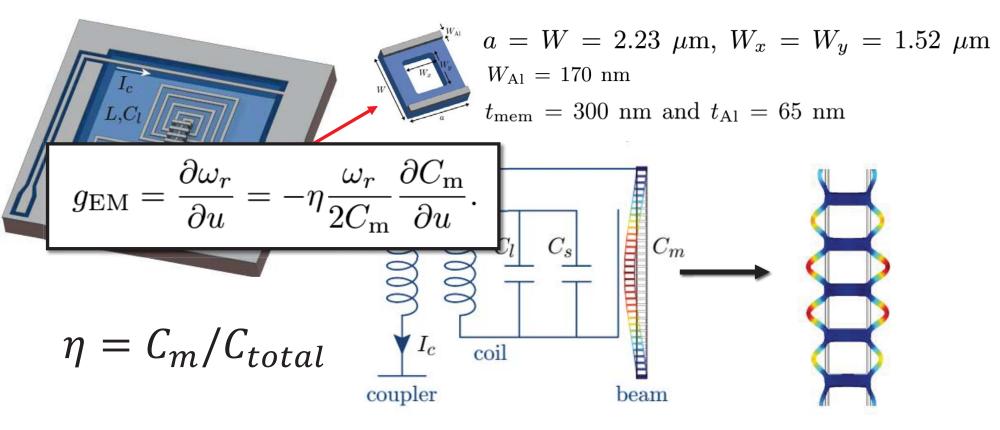
Reduce coupling to the environment by lowering temperature: microwave optomechanics

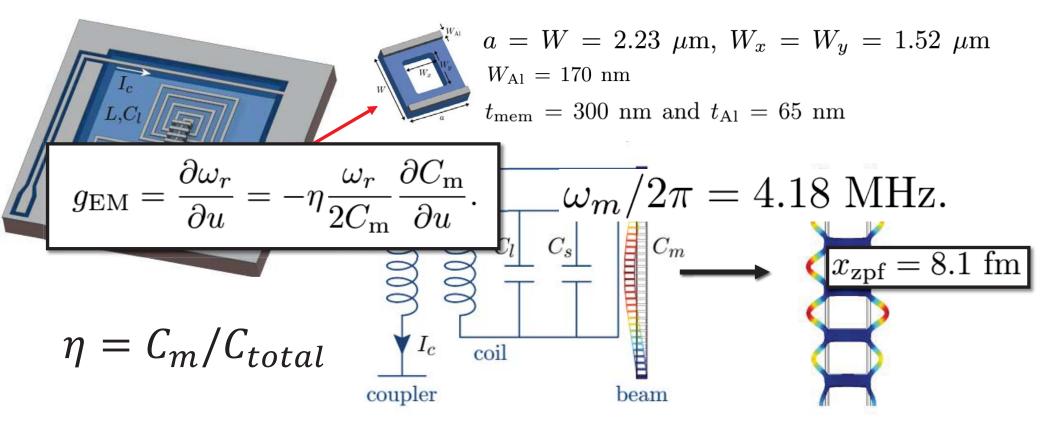
Microwave "light" in ultralow temperature cryostat

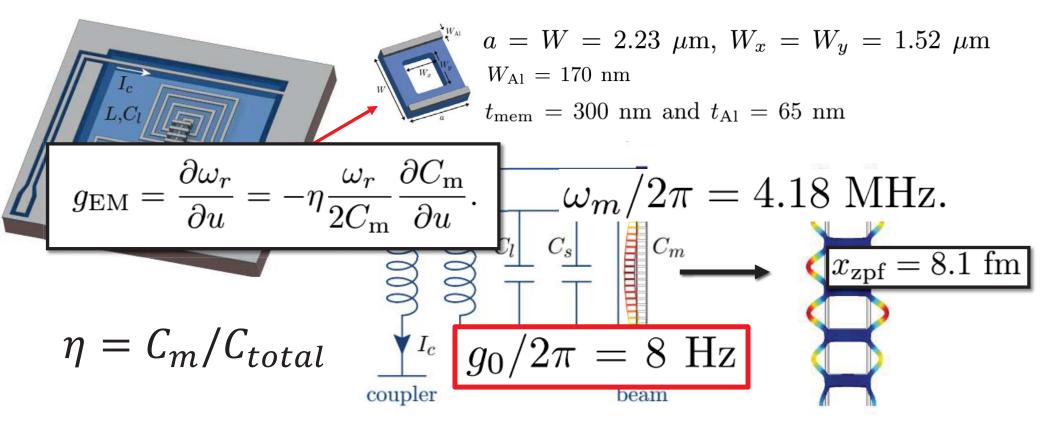


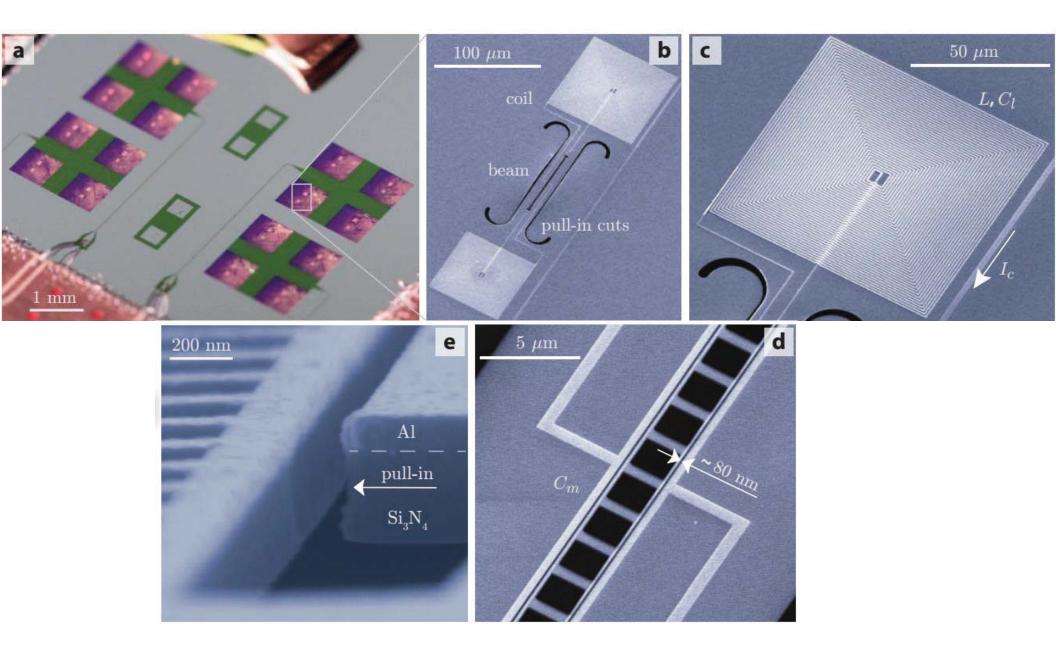


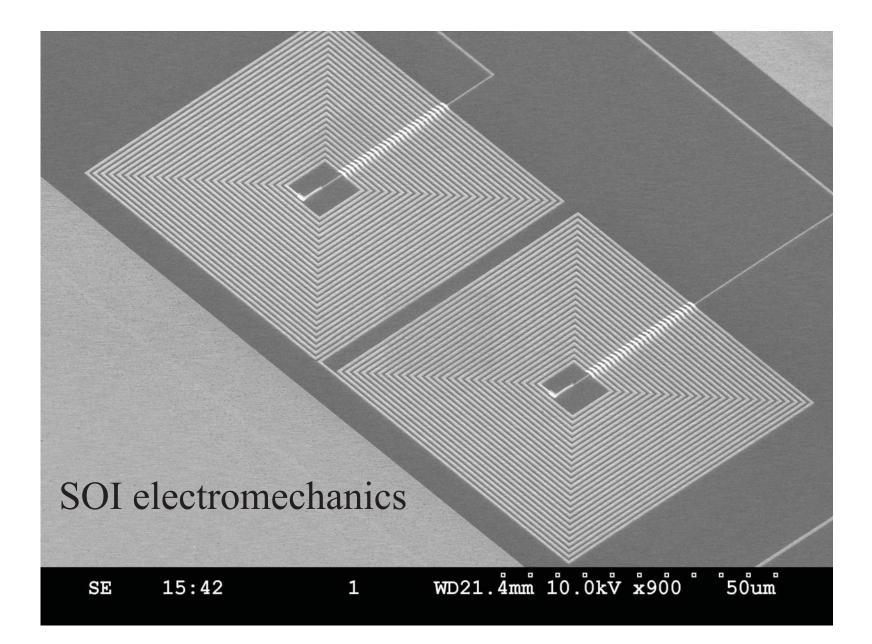


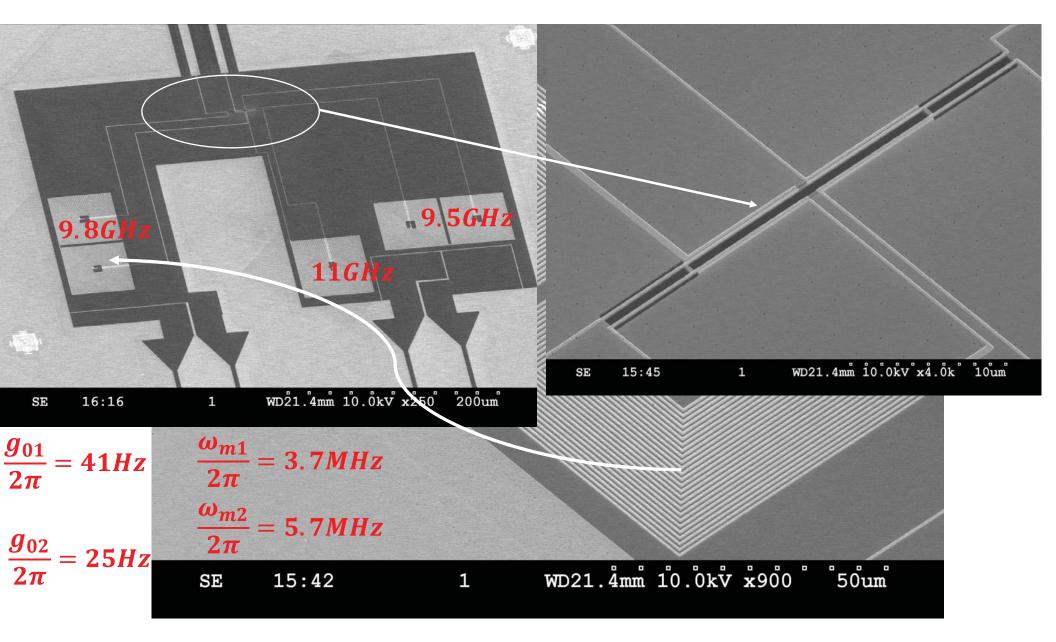










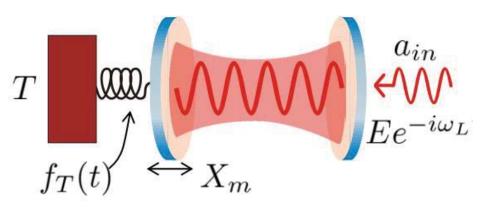


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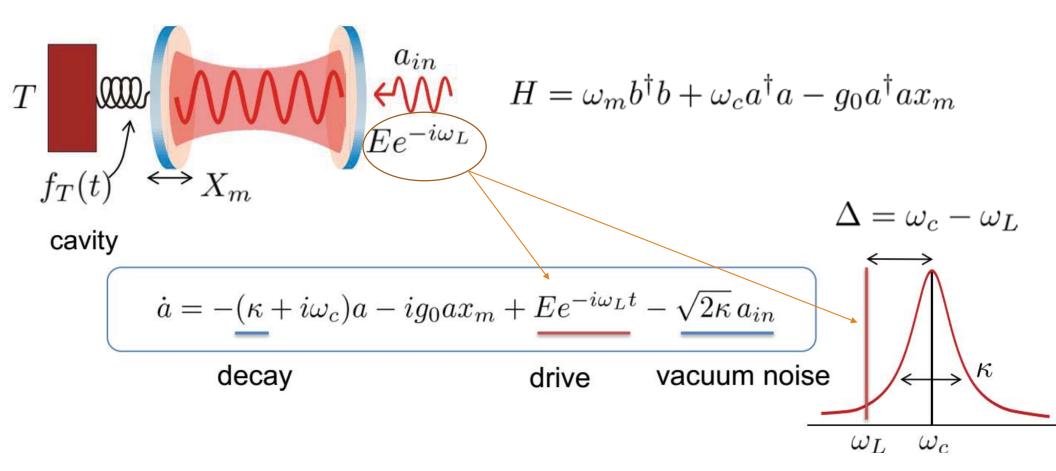
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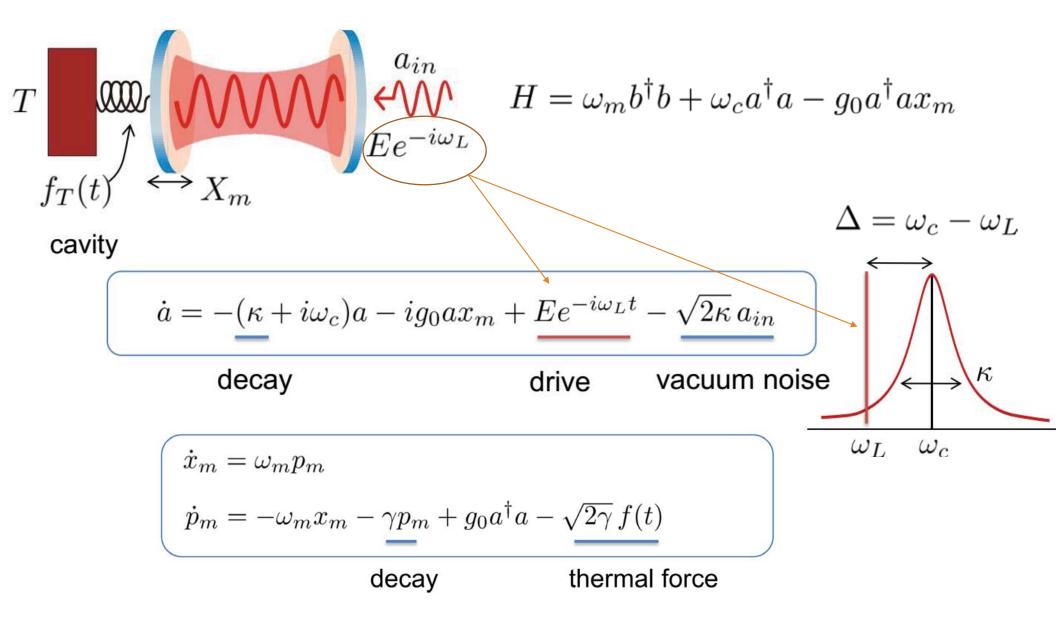
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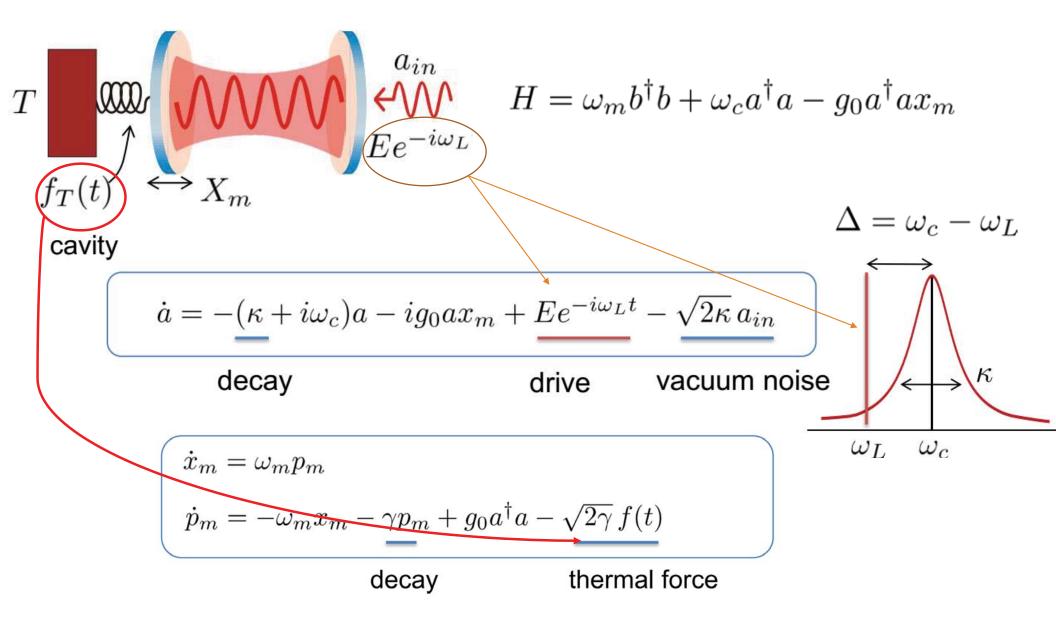
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$$H = \omega_m b^{\dagger} b + \omega_c a^{\dagger} a - g_0 a^{\dagger} a x_m$$







$$\dot{a} = -(\kappa - i\Delta)a - ig_0ax_m + E - \sqrt{2\kappa}a_{in}$$
$$\dot{x}_m = \omega_m p_m$$
$$\dot{p}_m = -\omega_m x_m - \gamma p_m + g_0 a^{\dagger}a - \sqrt{2\gamma} f_T(t)$$

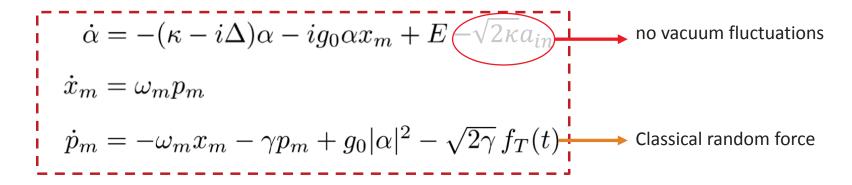
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$$\dot{x}_m = \omega_m p_m$$
$$\dot{p}_m = -\omega_m x_m - \gamma p_m + g_0 a^{\dagger}a - \sqrt{2\gamma} f_T(t)$$

Optomechanical Classical equations of motion

$$\dot{\alpha} = -(\kappa - i\Delta)\alpha - ig_0\alpha x_m + E - \sqrt{2\kappa}a_{in}$$
$$\dot{x}_m = \omega_m p_m$$
$$\dot{p}_m = -\omega_m x_m - \gamma p_m + g_0 |\alpha|^2 - \sqrt{2\gamma} f_T(t)$$

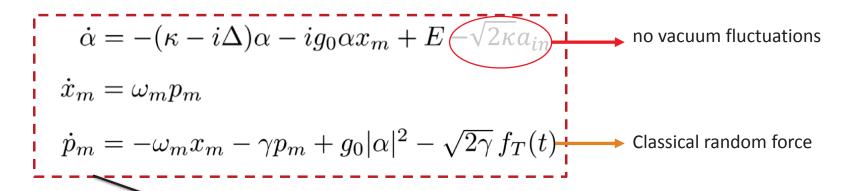
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Optomechanical Classical equations of motion



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Optomechanical Classical equations of motion



multistability, self induced oscillations, chaos,...

Analyze the **quantum** dynamics around classical mean values due to classical random forces and quantum noise on mirror and cavity

$\delta a = a - \bar{\alpha}$	$\bar{\alpha}$	>>>	1	$[\delta a, \delta a^\dagger] = 1$
$\delta x_m = x_m - \bar{x}_m$				$[\delta x_m, \delta p_m] = i$
$\delta p_m = p_m - \bar{p}_m$				[••••••••••••••••••••••••••••••••••••••

$$\delta \dot{x}_m = \omega_m \delta p_m$$

$$\delta \dot{a} = -(\kappa - i\Delta)\delta a - ig_0\bar{\alpha}\,\delta x_m - ig_0\,\delta a\delta x_m - \sqrt{2\kappa}\,a_{in}$$
$$\delta \dot{p}_m = -\omega_m\delta x_m - \gamma\delta p_m + g_0\bar{\alpha}(\delta a + \delta a^{\dagger}) + g_0\delta a^{\dagger}\delta a - \sqrt{2\gamma}\,f_T(t)$$

Analyze the **quantum** dynamics around classical mean values due to classical random forces and quantum noise on mirror and cavity

$\delta a = a - \bar{\alpha}$	$\overline{\alpha}$	\gg	1	$[\delta a, \delta a^\dagger] = 1$
$\delta x_m = x_m - \bar{x}_m$				$[\delta x_m, \delta p_m] = i$
$\delta p_m = p_m - \bar{p}_m$				$[\circ m, \circ pm] = \circ$

$$\begin{split} \delta \dot{x}_m &= \omega_m \delta p_m \\ \delta \dot{a} &= -(\kappa - i\Delta)\delta a - ig_0 \bar{\alpha} \delta x_m - ig_0 \,\delta a \delta x_m - \sqrt{2\kappa} \,a_{in} \\ \delta \dot{p}_m &= -\omega_m \delta x_m - \gamma \delta p_m + g_0 \bar{\alpha} (\delta a + \delta a^{\dagger}) + g_0 \delta a^{\dagger} \delta a - \sqrt{2\gamma} \,f_T(t) \end{split}$$

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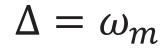
$$\begin{split} \delta \dot{x}_m &= \omega_m \delta p_m & g = g_0 \overline{\alpha} & \text{Small nonlinear term } \overline{\alpha} \gg 1 \\ \delta \dot{a} &= -(\kappa - i\Delta)\delta a - ig_0 \overline{\alpha} \delta x_m - ig_0 \delta a \delta x_m - \sqrt{2\kappa} a_{in} \\ \delta \dot{p}_m &= -\omega_m \delta x_m - \gamma \delta p_m + g_0 \overline{\alpha} (\delta a + \delta a^{\dagger}) + g_0 \delta a^{\dagger} \delta a - \sqrt{2\gamma} f_T(t) \end{split}$$

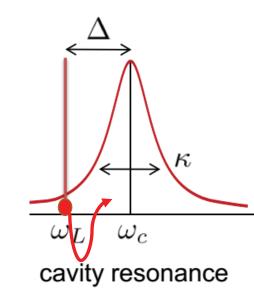
An and
$$\delta \dot{a} = -(\kappa - i\Delta)\delta a - ig\,\delta x_m - \sqrt{2\kappa}\,a_{in}$$

 $\delta \dot{x}_m = \omega_m \delta p_m$
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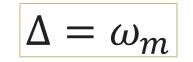
 $\delta \dot{p}_m = -\omega_m \delta x_m - \gamma \delta p_m + g_0 \bar{\alpha} (\delta a + \delta a^{\dagger}) + g_0 \delta a^{\dagger} \delta a - \sqrt{2\gamma} f_T(t)$

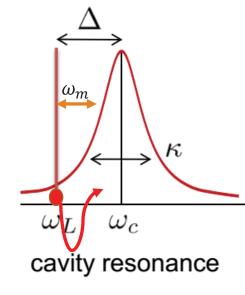
Optomechanical cooling





Optomechanical cooling



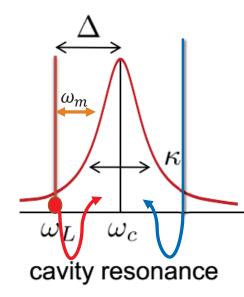


Anti-Stokes scattering

 $\omega_L \rightarrow \omega_L + \omega_m$ + annihilation of one phonon

Optomechanical cooling

 $\Delta = \omega_m$

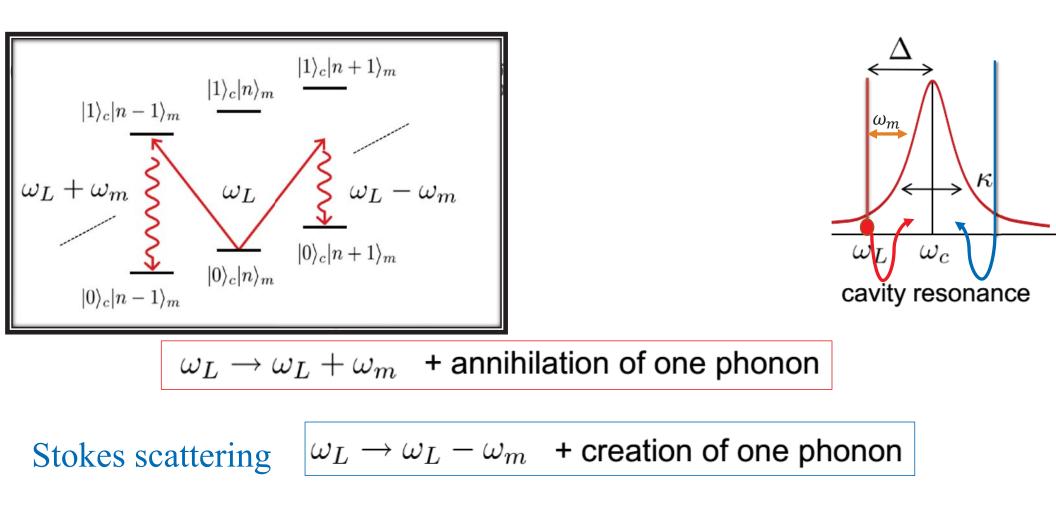


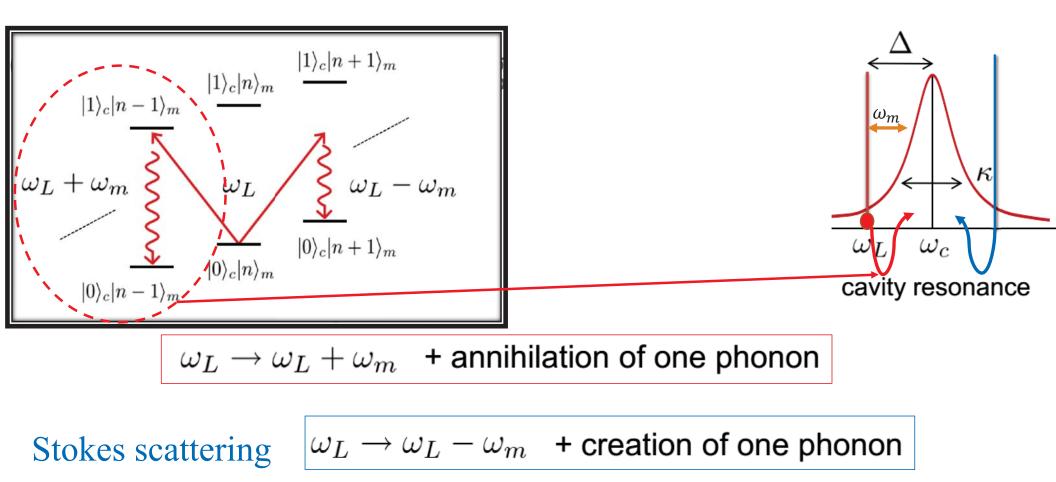
Anti-Stokes scattering

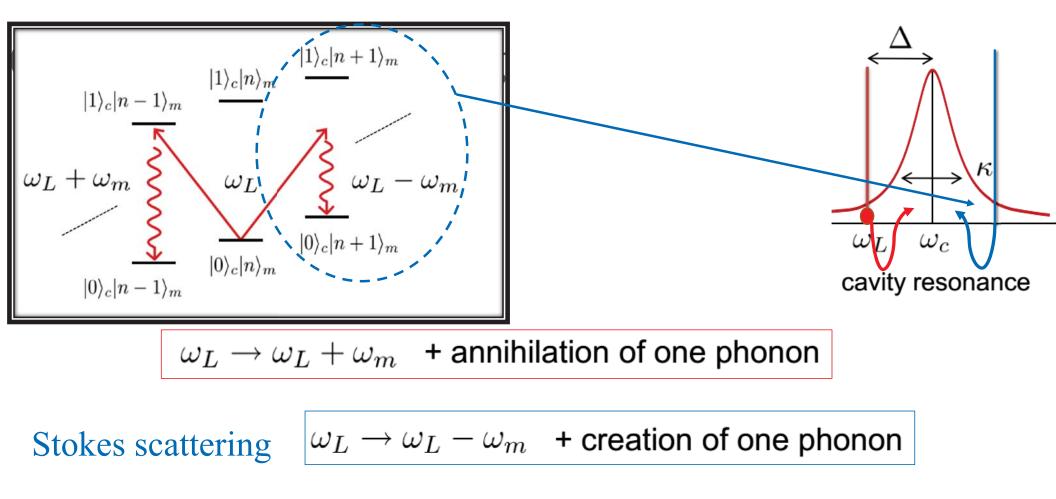
 $\omega_L \rightarrow \omega_L + \omega_m$ + annihilation of one phonon

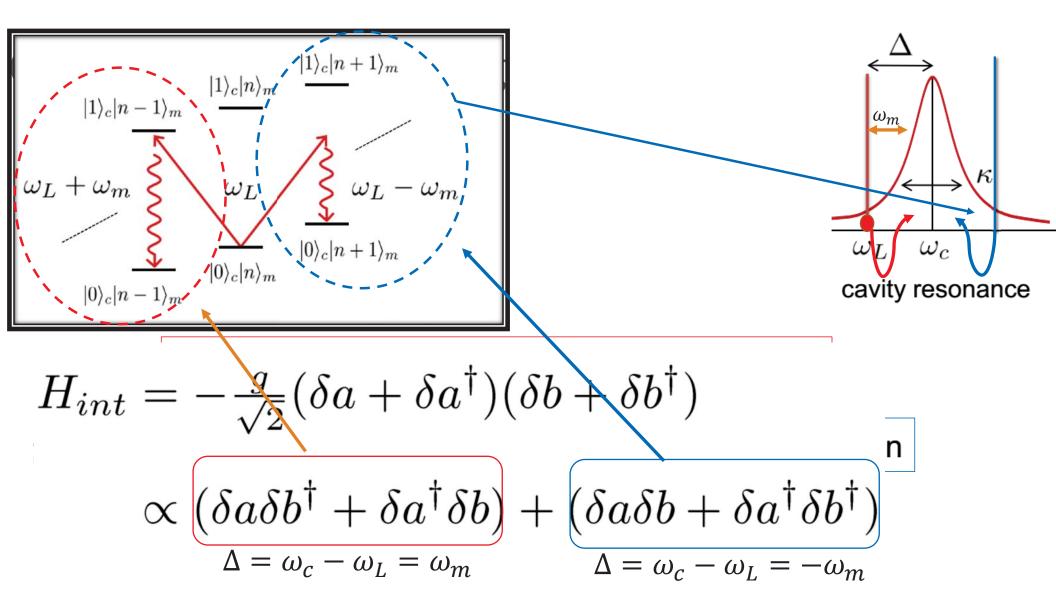
Stokes scattering

 $\omega_L
ightarrow \omega_L - \omega_m$ + creation of one phonon









♦ Cavity field mediates mechanical cooling, weak coupling regime $g \ll \kappa \ll \omega_m$

$$\delta a(t) \simeq -\frac{ig}{\sqrt{2}} \left(\frac{1}{\kappa} \,\delta b(t) + \frac{1}{2i\omega_m} \,\delta b^{\dagger}(t) \right) - \frac{\sqrt{2\kappa}}{i\omega_m} \,a_{in}(t)$$

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backaction
$$\delta \dot{b} = -(\gamma + i\omega_m) \delta b - \frac{ig}{\sqrt{2}} \left(\delta a + \delta a^{\dagger} \right) - \sqrt{2\gamma} \,f_T(t)$$

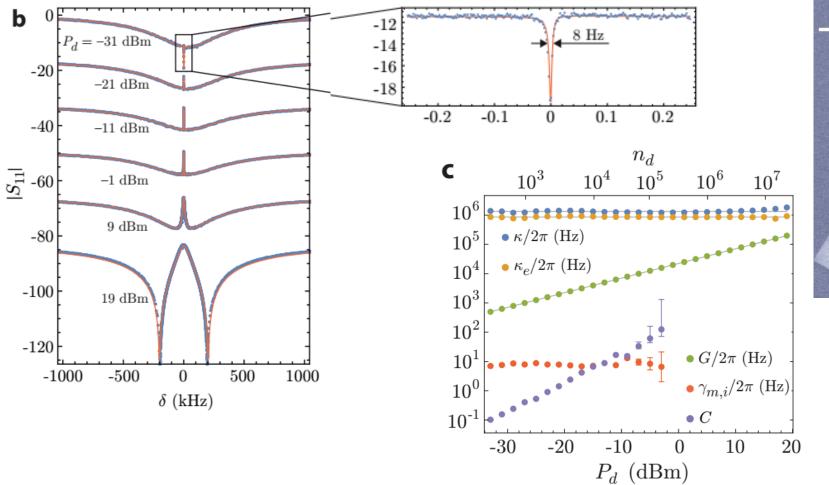
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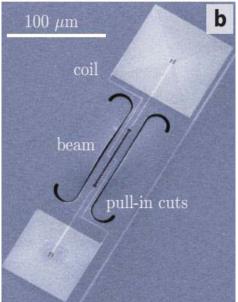
$$\begin{split} \delta a(t) &\simeq -\frac{ig}{\sqrt{2}} \left(\frac{1}{\kappa} \, \delta b(t) + \frac{1}{2i\omega_m} \, \delta b^{\dagger}(t) \right) - \frac{\sqrt{2\kappa}}{i\omega_m} \, a_{in}(t) \\ \delta \dot{b} &= -(\gamma + i\omega_m) \delta b - \frac{ig}{\sqrt{2}} \left(\delta a + \delta a^{\dagger} \right) - \sqrt{2\gamma} \, f_T(t) \end{split}$$
backaction
$$\delta \dot{b} &= -\left[\left(\gamma + \frac{g^2}{2\kappa} \right) + i \left(\omega_m + \frac{g^2}{4\omega_m} \right) \right] \delta b + \frac{g\sqrt{\kappa}}{\omega_m} (a_{in} - a^{\dagger}_{in}) - \sqrt{2\gamma} \, f_T(t) \end{aligned}$$
optomechanical cooling rate:
$$\Gamma = \frac{g^2}{2\kappa} \qquad \text{Optical spring effect(softening)}$$

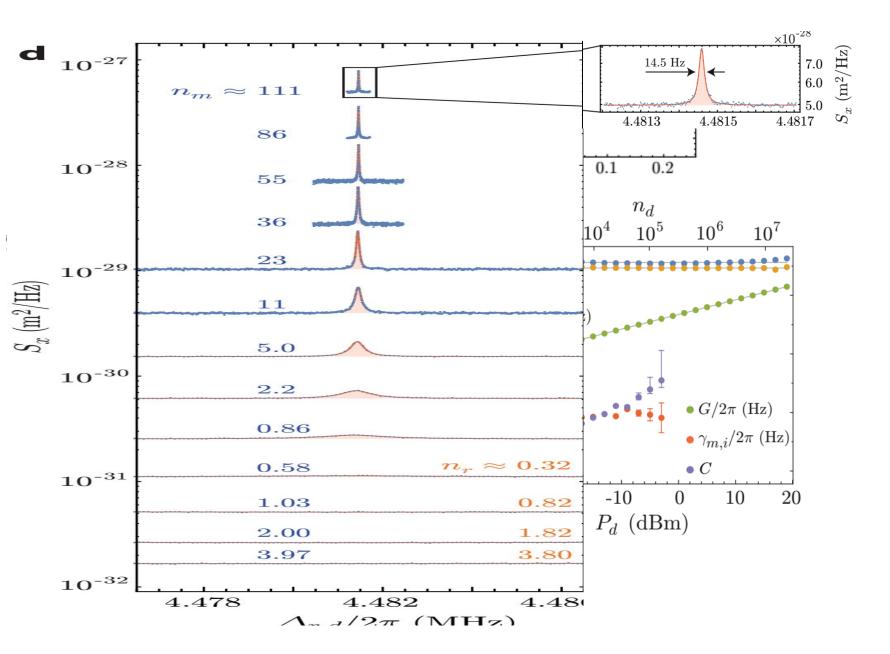
Average number of phonons in steady state

using
$$\langle a_{in}(t)a_{in}^{\dagger}(t')\rangle = \delta(t-t')$$
 vacuum noise
 $\langle f_T(t)f_T(t')\rangle \simeq \bar{n}_T\delta(t-t')$ thermal noise $\bar{n} \simeq \frac{k_BT}{\bar{h}\omega_m}$
 $\left(\langle \delta b^{\dagger}\delta b\rangle = \frac{\Gamma}{\gamma+\Gamma}\left(\frac{\kappa}{\omega_m}\right)^2 + \frac{\gamma}{\gamma+\Gamma}\bar{n}_T \simeq \left(\frac{\kappa}{\omega}\right)^2$
for efficient cooling $\gamma \bar{n}_T \ll \Gamma$
summary of ground state cooling conditions:
• red detuned drive $\Delta = \omega_m$
• sideband resolution $\omega_m \gg \kappa$
• strong coupling
 $\gamma \bar{n}_T \ll \Gamma$ $g^2 \gg (\gamma \bar{n}_T)\kappa$

 $\omega_L \omega_c$

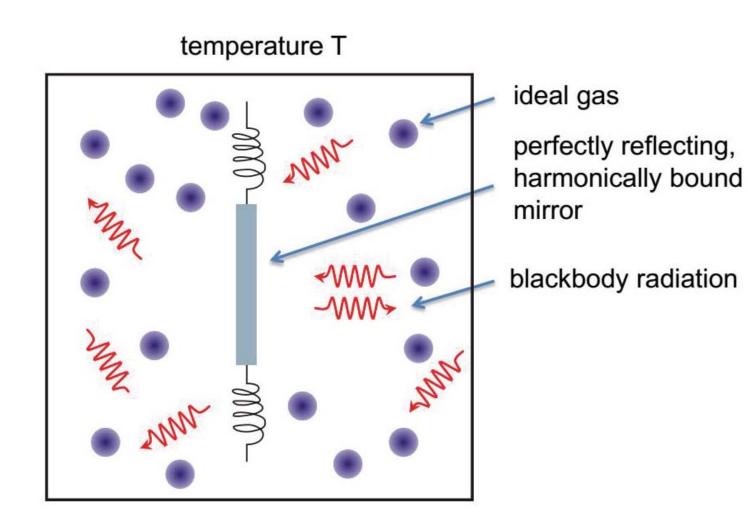


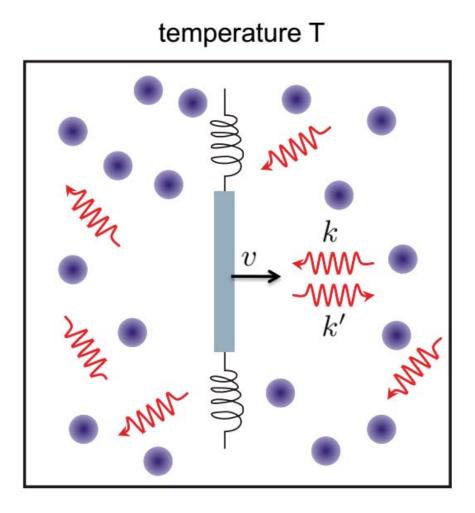




Conclusion

- > Applications of mechanical resonators
- Physic of mechanical resonators
- > Optomechanical cavities
- Microwave eletromechanics
- >Optomechanical cooling





Doppler shift of reflected wave:

$$k' = -k\left(1 - \frac{2v}{c}\right)$$

Radiation pressure force due to momentum $\sim k - k'$ transfer on mirror:

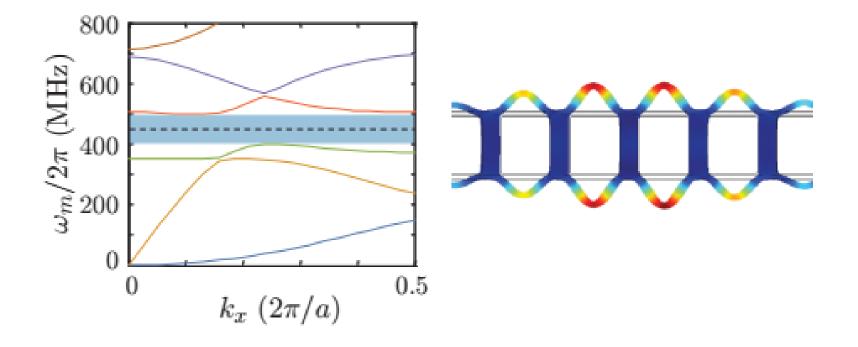
$$F_{\rm rp} = -\frac{2P}{c} \left(1 - \frac{v}{c}\right)$$
 power P

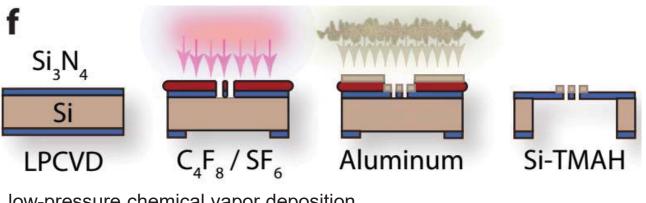
Radiation provides friction:

$$\dot{p} = -\gamma p$$
 $\gamma = \frac{2P}{mc^2}$

"Doppler cooling" of mirror

Thermal equilbrium?





low-pressure chemical vapor deposition (LPCVD)

(i) LPCVD of stoichiometric Si3N4 on both sides of a 200 μ m thick silicon substrate, (ii) C4F8:SF6 plasma etch through the nitride membrane defining the mechanical beam resonator and pull-in cuts on the top side, and membrane windows on the bottom side, (iii) electron beam lithography, aluminum deposition, and lift-off steps to pattern the microwave circuit

(iv) final release of the nitride membrane using a silicon-enriched tetramethylammonium hydroxide (TMAH) solution

1 cm × 1 cm chips diced from a high-resistivity siliconon-insulator (SOI) wafer manufactured by SOITEC using the Smart Cut process [22]. The SOI wafer consists of a 300 nm thick silicon device layer with (100) surface orientation and p-type (Boron) doping with a specified resistivity of 500 Ω -cm. Underneath the device layer is a 3 μ m buried silicon dioxide (SiO₂) BOX layer. The device and BOX layers sit atop a silicon (Si) handle wafer of thickness 675 μ m and a specified resistivity of 750 Ω cm. Both the Si device layer and handle wafer are grown using the Czochralski crystal growth method. Fabrication of the coupled coil resonator and H-slot resonator can be broken down into the following six steps. In step (1), we pattern the H-slot resonator using electron beam (e-beam) lithography in ZEP-520A resist, and etch this pattern into the Si device layer using an inductively coupled plasma reactive ion etch (ICP-RIE). After the ICP-RIE etch, we clean the chips with a 4 min piranha bath and a 12 sec buffered hydrofluoric acid (BHF) dip. In step (2), we pattern the capacitor electrodes and ground plane region using ZEP-520A resist and use electron beam evaporation to deposit 60 nm of AI on the chip. In step (3), we define a protective scaffold formed

out of LOR 5B e-beam resist to create the crossover re-